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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Pan et al.

Serial No.: 09/259,145

Filed: February 26, 1999

For: WELL-DRIVE ANNEAL
TECHNIQUE USING PREPLACEMENT
OF NITRIDE FILMS FOR ENHANCED
FIELD ISOLATION

Examiner: A. Mai

Group Art Unit: 2814

Attorney Docket No.: 3027.1US
(96-684.1)



CERTIFICATE OF MAILING

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Samuel E. Webb
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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed August 28, 2000, the three-month shortened statutory period for response to which expires on November 28, 2000.

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